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Mail Stop Patent Application
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Alexandria, VA 22313-1450

PATENT
Attorney Docket No.: A4356/T035310
AMAT No.: 4356 USA
D01/DSM/HDP/CVD/JW
TTC No.: 016301-035310US

On September 8, 2003

TOWNSEND and TOWNSEND and CREW LLP

By: Nina L. McNeill
Nina L. McNeill

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Tetsuya Ishikawa et al.

Application No.: Not yet assigned

Filed: Not yet assigned

For: METHOD OF REDUCING
PLASMA CHARGE DAMAGE FOR
PLASMA PROCESSES

Examiner: Not yet assigned

Art Unit: Not yet assigned

**INFORMATION DISCLOSURE
STATEMENT UNDER 37 CFR §1.97 and
§1.98**

Mail Stop Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The references cited on attached form PTO/SB/08A and PTO/SB/08B are being called to the attention of the Examiner. This application is a divisional application and claims priority to U.S. Appl. No. 09/771,203 filed January 26, 2001 (the "parent application"). All of the references were submitted to or cited by the U.S. Patent and Trademark Office in the parent application. Therefore, copies of the references are not enclosed. It is respectfully requested that the cited references be expressly considered during the prosecution of this application, and the references be made of record therein and appear among the "references cited" on any patent to issue therefrom.

As provided for by 37 CFR 1.97(g) and (h), no inference should be made that the information and references cited are prior art merely because they are in this statement and no representation is being made that a search has been conducted or that this statement encompasses all the possible relevant information.

Applicant believes that no fee is required for submission of this statement. However, if a fee is required, the Commissioner is authorized to deduct such fee from the undersigned's Deposit Account No. 20-1430. Please deduct any additional fees from, or credit any overpayment to, the above-noted Deposit Account.

Respectfully submitted,

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60031345 v1

Substitute for form 1449A/PTO			<i>C mplete if Known</i>	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>			Application Number	
			Filing Date	
			First Named Inventor	Ishikawa, Tetsuya
			Art Unit	Not yet assigned
			Examiner Name	Not yet assigned
Sheet	1	of	Attorney Docket Number	A4356/T35310

U.S. PATENT DOCUMENTS+					
Examiner Initials*	Cite No. ¹	Document Number Number Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
	AA	US-5,451,435	9/19/1995	Yu	
	AB	US-5,522,934	6/7/1996	Suzuki et al.	
	AC	US-5,614,055	03/1997	Fairbairn et al.	
	AD	US2001/00313 21 A1	10/18/2001	Ishikawa	
	AE	US-			
	AF	US-			
	AG	US-			
	AH	US-			
	AI	US-			
	AJ	US-			
	AK	US-			
	AL	US-			
	AM	US-			
	AN	US-			
	AO	US-			
	AP	US-			
	AQ	US-			
	AR	US-			
	AS	US-			
	AT	US-			

FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Foreign Patent Document		Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code ³	Number ⁴ Kind Code ⁵ (if known)		
	AU	PCT	WO 99/57747	Applied Materials, Inc.	<input type="checkbox"/>
	AV	PCT	WO 01/03159 A1	Dhindsa et al.	<input type="checkbox"/>
	AW				<input type="checkbox"/>
	AX				<input type="checkbox"/>
	AY				<input type="checkbox"/>
	AZ				<input type="checkbox"/>
	BA				<input type="checkbox"/>
	BB				<input type="checkbox"/>

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional) ² Kind Codes of U.S. Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

Substitute for form 1449B/PTO				<i>Complete if Known</i>	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT				<i>Application Number</i>	
(use as many sheets as necessary)				<i>Filing Date</i>	
Sheet	2	of		<i>First Named Inventor</i>	Ishikawa, Tetsuya
				<i>Art Unit</i>	Not yet assigned
				<i>Examiner Name</i>	Not yet assigned
				<i>Attorney Docket Number</i>	A4356/T35310

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
	BC	GYEONG S. HWANG et al., "Modeling of charging damage during interlevel oxide deposition in high-density plasma," Journal of Applied Physics, Vol. 84, Number 1, July 1998, pp. 154-160.		T ²
	BD			
	BE			
	BF			

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